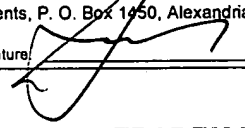


CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on the below date:

Date: May 30, 2006 Name: Gustavo Siller, Jr. Signature: 

**BRINKS
HOFFER
GILSON
& LIONE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Re Appln. of: **Tetsuya Fukuda et al.**

Appln. No.: **10/721,664**

Examiner: **Daniel Petkovsek**

Art Unit: **2874**

Filed: **November 25, 2003**

For: **ANTI-REFLECTIVE STRUCTURE,
ILLUMINATING DEVICE, LIQUID
CRYSTAL DEVICE, AND MOLD FOR
FORMING ANTI-REFLECTIVE FILM**

Attorney Docket No: **9281-4714**

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL

Sir:

Attached is/are:

- ☒ Transmittal Letter, Supplemental Information Disclosure Statement, PTO-1449, and cited references B3-B12.
- ☒ Return Postcard

Fee calculation:

- ☐ No additional fee is required.
- ☐ An extension fee in an amount of \$_____ for a _____-month extension of time under 37 C.F.R. § 1.136(a).
- ☐ A petition or processing fee in an amount of \$_____ under 37 C.F.R. § 1.17(_____).
- ☐ An additional filing fee has been calculated as shown below:

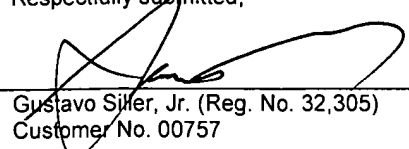
					Small Entity			Not a Small Entity	
	Claims Remaining After Amendment		Highest No. Previously Paid For	Present Extra	Rate	Add'l Fee	or	Rate	Add'l Fee
Total		Minus			x \$9=			x \$18=	
Indep.		Minus			x 43=			x \$86=	
First Presentation of Multiple Dep. Claim					+\$145=			+\$290=	
					Total	\$		Total	\$

Fee payment:

- ☐ A check in the amount of \$_____ to cover the above-identified fee(s) is enclosed.
- ☐ Please charge Deposit Account No. 23-1925 in the amount of \$_____. A copy of this Transmittal is enclosed for this purpose.
- ☐ Payment by credit card in the amount of \$_____ (Form PTO-2038 is attached).
- ☒ The Director is hereby authorized to charge payment of any additional filing fees required under 37 CFR § 1.16 and any patent application processing fees under 37 CFR § 1.17 associated with this paper (including any extension fee required to ensure that this paper is timely filed), or to credit any overpayment, to Deposit Account No. 23-1925.

Respectfully submitted,

May 30, 2006
Date


Gustavo Siller, Jr. (Reg. No. 32,305)
Customer No. 00757



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. of: Tetsuya Fukuda et al.

Appln. No.: 10/721,664

Filed: November 25, 2003

For: ANTI-REFLECTIVE
STRUCTURE, ILLUMINATING
DEVICE, LIQUID CRYSTAL
DEVICE, AND MOLD FOR
FORMING ANTI-REFLECTIVE
FILM

Examiner: Daniel Petkovsek

Art Unit: 2874

Attorney Docket No: 9281-4714

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98, and more particularly in accordance with 37 C.F.R. §1.97(c), Applicants hereby cite the following reference(s):

No.	Date of Publication
WO 01/35128	05-17-2001
1 008 870	06-14-2000
2002/0135869	09-26-2002
WO 01/29148	04-26-2001
6,375,870	04-23-2002
WO 98/33006	07-30-1998

Other Art
"The Optical Properties of 'Moth Eye' Antireflection Surfaces"; Wilson S. J. et al; Optica Acta, XX, XX, Vol. 29, No. 7, 1982, pages 993-1009, XP000613779
"Experimental Demonstration of Resonant Anomalies In Diffraction from Two-Dimensional Gratings"; Peng S. et al.; Optics Letters, OSA, Optical Society of America, Washington, DC, US, Vol. 21, No. 8; 15 April 1996 (1996-04-15); pages 549-551; XP000589922
"Antireflection Structured Surfaces for the Infrared Spectral Region"; Raguin D. H. et al; Applied Optics, OSA, Optical Society of America, Washington, DC, US, Vol. 32, No. 7; 1 March 1993 (1993-03-01); pages 1154-1167; XP000345959
"High-Spatial-Frequency Binary and Multilevel" High-Stairstep Gratings: Polarization-Selective Mirrors and Broadband Antireflection Surfaces"; Glytsis E. N. et al; Applied Optics, OSA, Optical Society of America,

Washington, DC, US, Vol. 31, No. 22; 1 August 1992 (1992-08-01); pages 4459-4470; XP000292091
"Formation of Antireflection Microstructures on the Surfaces of Diamond Plates by the Laser Patterning Method"; Kononenko V. V. et al.; Quantum Electronics, Turpion Ltd., London, GB, Vol. 29, No. 2; February 1999 (1999-02); pages 158-162; XP000847233

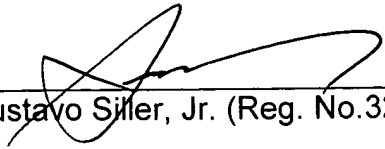
Applicants are enclosing Form PTO-1449 (one sheet), along with a copy of each listed reference for which a copy is required under 37 C.F.R. §1.98(a)(2). As each of the listed references is in English, no further commentary is believed to be necessary, 37 C.F.R. §1.98(a)(3). Also enclosed is a copy of the Search Report dated March 1, 2006 for corresponding European Patent Application No. 03 257 421.2. Applicants respectfully request the Examiner's consideration of the above reference(s) and entry thereof into the record of this application.

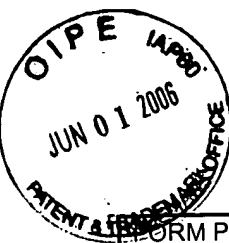
By submitting this Statement, Applicants are attempting to fully comply with the duty of candor and good faith mandated by 37 C.F.R. §1.56. As such, this Statement is not intended to constitute an admission that any of the enclosed references, or other information referred to therein, constitutes "prior art" or is otherwise "material to patentability," as that phrase is defined in 37 C.F.R. §1.56(a).

Applicants certify pursuant to 37 C.F.R. §1.97(e)(1) that no item of information in this Statement was first cited in any communication from a foreign patent office in a counterpart foreign application more than three months days prior to the filing of this Statement (a copy of any foreign communication first citing a listed reference is attached for the Examiner's reference). Accordingly, Applicants have calculated no fee to be due in connection with the filing of this Statement. However, the Director is authorized to charge any fee deficiency associated with the filing of this Statement to a deposit account, as authorized in the Transmittal accompanying this Statement.

Respectfully submitted,

May 30, 2006
Date


Gustavo Siller, Jr. (Reg. No. 32,305)



FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)	SERIAL NO. 10/721,664	CASE NO. 9281-4714
	FILING DATE November 25, 2003	GROUP ART UNIT 2874
	APPLICANT(S): Tetsuya Fukuda et al.	

REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS				
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
	B1	2002/0135869	09-26-2002	Michele Banish et al.		
	B2	6,375,870	04-23-2002	Nick J. Visovsky		

FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES	TRANSLATION NO
	B3	WO 01/35128	05-17-2001	PCT		X	
	B4	1 008 870	06-14-2000	Europe		X	
	B5	WO 01/29148	04-26-2001	PCT		X	
	B6	WO 98/33006	07-30-1998	PCT		X	

EXAMINER INITIAL	OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)	
	B7	Copy of Search Report dated March 1, 2006 for corresponding European Patent Application No. 03 257 421.2.
	B8	"The Optical Properties of 'Moth Eye' Antireflection Surfaces"; Wilson S. J. et al; Optica Acta, XX, XX, Vol. 29, No. 7, 1982, pages 993-1009, XP000613779.
	B9	"Experimental Demonstration of Resonant Anomalies In Diffraction from Two-Dimensional Gratings"; Peng S. et al.; Optics Letters, OSA, Optical Society of America, Washington, DC, US, Vol. 21, No. 8; 15 April 1996 (1996-04-15); pages 549-551; XP000589922.
	B10	"Antireflection Structured Surfaces for the Infrared Spectral Region"; Raguin D. H. et al; Applied Optics, OSA, Optical Society of America, Washington, DC, US, Vol. 32, No. 7; 1 March 1993 (1993-03-01); pages 1154-1167; XP000345959.
	B11	"High-Spatial-Frequency Binary and Multilevel" High-Stairstep Gratings: Polarization-Selective Mirrors and Broadband Antireflection Surfaces"; Glytis E. N. et al; Applied Optics, OSA, Optical Society of America, Washington, DC, US, Vol. 31, No. 22; 1 August 1992 (1992-08-01); pages 4459-4470; XP000292091.
	B12	"Formation of Antireflection Microstructures On the Surfaces of Diamond Plates by the Laser Patterning Method"; Kononenko V. V. et al.; Quantum Electronics, Turpion Ltd., London, GB, Vol. 29, No. 2; February 1999 (1999-02); pages 158-162; XP000847233
EXAMINER		DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.